

| L Number | Hits  | Search Text  | DB  | Time stamp       |
|----------|-------|--|---|------------------|
| 33       | 22799 | ((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical))) ) (microfabricat\$3 or (micro adj fabricat\$3)) ) (micromachin\$3 or (micro adj machin\$3) )  | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 12:43 |
| 40       | 0     | US-20020001051-A1.DID. near20 (seal\$3 cover\$3 cap\$4)  | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 13:37 |
| 111      | 1374  | (sacrificial disposable) near12 (polyimide photoresist)  | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 12:55 |
| 118      | 467   | ((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical))) ) (microfabricat\$3 or (micro adj fabricat\$3)) ) (micromachin\$3 or (micro adj machin\$3) ) ) and ((sacrificial disposable) near12 (polyimide photoresist))  | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 12:55 |
| 125      | 1730  | ((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical))) ) (microfabricat\$3 or (micro adj fabricat\$3)) ) (micromachin\$3 or (micro adj machin\$3) ) ) near20 (seal\$3 cover\$3 cap\$4)   | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 13:05 |
| 132      | 72    | ((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical))) ) (microfabricat\$3 or (micro adj fabricat\$3)) ) (micromachin\$3 or (micro adj machin\$3) ) ) near20 (seal\$3 cover\$3 cap\$4) and ((sacrificial disposable) near12 (polyimide photoresist))   | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 13:05 |
| 139      | 22    | ((lid cap\$4 cover\$3\$3) near12 (metal aluminum)) and (((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical))) ) (microfabricat\$3 or (micro adj fabricat\$3)) ) (micromachin\$3 or (micro adj machin\$3) ) ) near20 (seal\$3 cover\$3 cap\$4) and ((sacrificial disposable) near12 (polyimide photoresist)))    | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 13:34 |
| 146      | 974   | ((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical))) ) (microfabricat\$3 or (micro adj fabricat\$3)) ) (micromachin\$3 or (micro adj machin\$3) ) ) near20 (seal\$3 cover\$3 capped cap capping)   | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 13:05 |
| 153      | 35    | ((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical))) ) (microfabricat\$3 or (micro adj fabricat\$3)) ) (micromachin\$3 or (micro adj machin\$3) ) ) near20 (seal\$3 cover\$3 capped cap capping) and ((sacrificial disposable) near12 (polyimide photoresist))   | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 13:05 |
| 160      | 22    | ((lid cap\$4 cover\$3) near12 (metal aluminum)) and (((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical))) ) (microfabricat\$3 or (micro adj fabricat\$3)) ) (micromachin\$3 or (micro adj machin\$3) ) ) near20 (seal\$3 cover\$3 cap\$4) and ((sacrificial disposable) near12 (polyimide photoresist)))       | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 13:40 |
| 167      | 0     | ((encapsul?nt encapsulat\$3) near12 (metal aluminum)) and (((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical))) ) (microfabricat\$3 or (micro adj fabricat\$3)) ) (micromachin\$3 or (micro adj machin\$3) ) ) near20 (seal\$3 cover\$3 cap\$4) and ((sacrificial disposable) near12 (polyimide photoresist))) | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 13:36 |

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|-----|-----|--|---|------------------|
| 174 | 275 | (sealed capped covered) near3 (MEMS microstructure microdevice micromechanical microelectromechanical microoptoelectromechanical microopto microoptic micromirror microoptomechanical micromachined microfabricated)   | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 13:39 |
| 181 | 66  | ((lid cap\$4 cover\$3) near12 (metal aluminum)) and ((sealed capped covered) near3 (MEMS microstructure microdevice micromechanical microelectromechanical microoptoelectromechanical microopto microoptic micromirror microoptomechanical micromachined microfabricated)) | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2002/12/14 13:40 |